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FILING OR 371 DRAWINGS TOT CLMS IND CLMS ART UNIT FIL FEE REC'D ATTY, DOCKET NO APPL NO. (c) DATE 3 2 770 TS01-167CD 10/706,495 11/12/2003 2812

**CONFIRMATION NO. 7230** 

George O. Saile 28 Davis Avenue Poughkeepsie, NY 12603 **FILING RECEIPT** OC000000011877764\*

Date Mailed: 02/11/2004

Receipt is acknowledged of this regular Patent Application. It will be considered in its order and you will be notified as to the results of the examination. Be sure to provide the U.S. APPLICATION NUMBER, FILING DATE, NAME OF APPLICANT, and TITLE OF INVENTION when inquiring about this application. Fees transmitted by check or draft are subject to collection. Please verify the accuracy of the data presented on this receipt. If an error is noted on this Filing Receipt, please write to the Office of Initial Patent Examination's Filing Receipt Corrections, facsimile number 703-746-9195. Please provide a copy of this Filing Receipt with the changes noted thereon. If you received a "Notice to File Missing Parts" for this application, please submit any corrections to this Filing Receipt with your reply to the Notice. When the USPTO processes the reply to the Notice, the USPTO will generate another Filing Receipt incorporating the requested corrections (if appropriate).

### Applicant(s)

Ying-Lang Wang, Tien-Chung Village, TAIWAN; Shih-Chi Lin, Taipei City, TAIWAN; Yi-Lung Cheng, Taipei, TAIWAN; Chi-Wen Liu, Hsinchu, TAIWAN; Ming-Hua Yoo, Ilan City, TAIWAN; Wen-Kung Cheng, Touten city, TAIWAN; Jiann-Kwang Wang, Hsin-Chu, TAIWAN;

### Assignment For Published Patent Application

TAIWAN SEMICONDUCTOR MANUFACTURING COMPANY;

### Domestic Priority data as claimed by applicant

This application is a DIV of 10/038,389 01/03/2002 PAT 6,660,638

#### Foreign Applications

If Required, Foreign Filing License Granted: 02/10/2004

Projected Publication Date: 05/20/2004

Non-Publication Request: No

Early Publication Request: No

Title

CMP process leaving no residual oxide layer or slurry particles

**Preliminary Class** 

438

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# GEORGE O. SAILE & ASSOCIATES 28 DAVIS AVENUE POUGHKEEPSIE, NY 12603

March 3, 2004

To:

Mail Stop: Application Number

**Commissioner For Patents** 

P.O. Box 1450

Alexandria, VA 22313-1450

From: Stephen B. Ackerman

Subject:

Serial No.:

10/706,495

Filing Date: 11/12/03

Inventor:

Y. L. Wang, et al.

Title:

CMP Process Leaving no Residual Oxide Layer or Slurry

**Particles** 

### REQUEST TO CORRECT FILING RECEIPT

Dear Sir:

On the copy of the enclosed Filing Receipt, there is an error in the list of Applicants. The sixth Applicant's residence is misspelled. Mr. Cheng's name and corrected residence reads; Wen-Kung Cheng, Toufen City, Taiwan.

Please make the necessary change to correct the error on the Filing Receipt.

If there are any questions, please contact the undersigned attorney at (845) 452-5863. Thank you for your attention to this matter.

Respectfully Submitted,

Stephen B. Ackerman, Reg. No, 37,761